



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Young-Chul Bang *et al.*

SERIAL NO.: 10/805,790

EXAMINER: Jarrett J. Stark

FILED: March 22, 2004

ART UNIT: 2823

FOR: METHOD OF GROWING SELECTIVE AREA BY METAL ORGANIC
CHEMICAL VAPOR DEPOSITION

AMENDMENT

Mail Stop Amendment
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated April 13, 2006, Applicant hereby requests amendment of the above-identified application as follows.